

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

JUN 28 2001
OIE

In re Application of:)
SHINICHI HARA, ET AL.) : Examiner: Not Assigned
Application No.: 09/818,625) : Group Art Unit: 2851
Filed: March 28, 2001) :
For: EXPOSURE APPARATUS, GAS) June 28, 2001
REPLACEMENT METHOD,)
SEMICONDUCTOR DEVICE)
MANUFACTURING METHOD,)
SEMICONDUCTOR MANUFACTURING))
FACTORY, AND EXPOSURE)
APPARATUS MAINTENANCE)
METHOD)

Box Missing Parts
The Commissioner for Patents
Washington, D.C. 20231

REQUEST FOR CORRECTED FILING RECEIPT

Sir:

Applicants' attorneys have received an official Filing Receipt in the above-identified application in which the following has changed:

**The Address of the Fourth Inventor, Toru HIRABAYASHI has changed from
“Tokyo, Japan” to --Tochigi, Japan--.**

Applicants request issuance of a corrected Filing Receipt, corrected as shown above, is accordingly respectfully requested.

The Commissioner is authorized to charge Deposit Account No. 06-1205 should any fees be deemed necessary for this correction. A duplicate of this paper is enclosed for this purpose.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Attorney for Applicants

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